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MTS-2700US1

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Yuji Judai : Art Unit:
Serial No.: To Be Assigned : Examiner:
Filed: Herewith :
FOR: SEMICONDUCTOR DEVICE AND :
ITS FABRICATION METHOD :
:

DIVISIONAL OF:

Applicant: Yuji Judai : Art Unit: 2814
Serial No.: 09/177,038 : Examiner: H. Weiss
Filed: October 22, 1998 :
FOR: SEMICONDUCTOR DEVICE :
HAVING A FERROELECTRIC :
CAPACITOR WITH TENSILE STRESS :
PROPERTIES :
:

PRELIMINARY AMENDMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

S I R :

Prior to examination, please amend the above-identified
application as follows:

IN THE TITLE:

Please delete the title in its entirety and substitute therefore: